IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: Christopher M Raabe
TAKESHI ICHIKAWA ET AL.	
Application No.: 10/516,545	: Art Unit: 2879
Filed: December 2, 2004	Conf. No.: 2864
For: ELECTRON-EMITTING DEVICE AND MANUFACTURING METHOD THEREOF	:) :) May 5, 2008

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

This Amendment is filed in response to the Office Action dated February 5, 2008. In response to that Office Action, please amend the above-identified application as follows: